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Patent
259/079
P01-0015

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

KENNY, Michael et al.

Serial No.: 09/925,884

Filed: August 6, 2001

For: Process And Apparatus For Treating
A Workpiece Such As A Semiconductor
Wafer

Group Art Unit: 1746

Examiner: Not yet assigned

TRANSMITTAL OF FORMAL DRAWINGS

Commissioner for Patents
Washington, D.C. 20231

Sir:

Transmitted herewith for filing in the above-referenced application are formal drawings

(11 sheets).

Respectfully submitted,
LYON & LYON LLP

Dated: November 15, 2001

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(37 C.F.R. §1.8a)

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